



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re Appln. of: Theodorus E. Standaert et al.

Appln. No.: 10/772,777

Filed: February 5, 2004

For: IN-SITU LINER FORMATION
DURING REACTIVE ION ETCH

Attorney Docket No: 10808/142

Examiner:

Art Unit: 2812

*Fee
only*

INFORMATION DISCLOSURE STATEMENT

In accordance with the duty of disclosure under 37 C.F.R. §1.56 and §§1.97-1.98, and more particularly in accordance with 37 C.F.R. §1.97(b), Applicants hereby cite the following reference(s):

Document No.	Date of Publication	Patentee/Applicant/Assignee
5,269,879	12/14/93	Rhoades et al.
6,211,061	04/03/2001	Chen et al.
6,468,898	10/22/2002	Usami
6,656,841	12/02/2003	Kim

OTHER ART - NON PATENT LITERATURE DOCUMENTS

International Search Report, International Application No. PCT/EP2005/050397,
International Filing Date January 31, 2005, 3 pages.

Applicants are enclosing Form PTO-1449 (one sheet), along with a copy of each listed reference for which a copy is required under 37 C.F.R. §1.98(a)(2). As each of the listed references is in English, no further commentary is believed to be necessary, 37 C.F.R §1.98(a)(3). Applicants respectfully request the Examiner's consideration of the above reference(s) and entry thereof into the record of this application.

By submitting this Statement, Applicants are attempting to fully comply with the duty of candor and good faith mandated by 37 C.F.R. §1.56. As such, this Statement is not intended to constitute an admission that any of the enclosed references, or other information referred to therein, constitutes "prior art" or is otherwise "material to patentability," as that phrase is defined in 37 C.F.R. §1.56(a).

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